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\*\* CONTINUING DATA \*\*\*\*\*  
NONE\*\* FOREIGN APPLICATIONS \*\*\*\*\*  
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Foreign Priority claimed ☒ yes ☐ no  
35 USC 119 (a-d) conditions met ☒ yes ☐ no ☐ Met after Allowance  
Verified and Acknowledged Examiner's Signature Initials

STATE OR  
COUNTRY  
JAPAN

SHEETS  
DRAWING  
5

TOTAL  
CLAIMS  
12

INDEPENDENT  
CLAIMS  
1

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## TITLE

Manufacturing method of a semiconductor substrate provided with a through hole electrode

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